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Applicant: Yasuaki Tsuzuki et al.
Serial No. 09/361,980
Filed: July 28, 1999
For: METHOD OF ETCHING METALLIC THIN FILM
RESISTOR

DECISION ON PETITION

This is a decision on the petition filed on May 2, 2002 under 37 C.F.R. 1.48(b) requesting that the inventorship of this application be corrected by deleting ICHIRO ITO, SATOSHI SHIRAKI, TOMIO YAMAMOTO, MAKOTO OHKAWA, and ATSUMI TAKAHASHI. Petitioner has met the requirements of 37 C.F.R. 1.48(b).

The petition is **GRANTED**.

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